

SEP 29 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, *et al.* Docket No.: 2001 P 11900 US01
Serial No.: 10/786,996 Art Unit: 1746
Filed: February 25, 2004 Examiner: Markoff, Alexander
For: Method of Removing PECVD Residues of Fluorinated Plasma Using In-Situ H₂ Plasma

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Examiner:

Applicant respectfully requests reconsideration of the claims in view of the following amendments and remarks, which are submitted as a full and complete response to the Examiner's Office Action dated June 29, 2005.